

FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE
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Sheet 1 of 1

OCT 07 2003

ATTORNEY DOCKET NO.

SERIAL NO.

45900-000611/US

09/867,606

APPLICANT

Ib JOHANNSEN et al.

FILING DATE

GROUP

May 31, 2001

2643

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date

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Technology Center 2600

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
	BL	Ning et al., "Fabrication of a silicon micromachined capacitive microphone using a dry-etch process" Sensors and Actuators A 53 (1996) 237-242

Examiner:

B. E. E.

Date Considered:

4/20/04

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